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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Hisashi NAKAMURA et al.**

Group Art Unit: **2675**

Application Number: **10/073,959**

Examiner: **Srilakshmi K. Kumar**

Filed: **February 14, 2002**

Confirmation Number: **8711**

For: **LIQUID CRYSTAL PROJECTOR COOLING SYSTEM DEPENDENT ON AIR PRESSURE AND TEMPERATURE VARIABLES (AS AMENDED)**

Attorney Docket Number: **0422288**  
Customer Number: **38834**

**REQUEST FOR STATUS**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

November 30, 2006

Sir:

The undersigned attorney requests the status of the above-identified application.

The application was filed on February 14, 2002 in the U.S. Patent and Trademark Office. To date, no Office Action has been received by Applicant. Applicant(s) respectfully request(s) the status of the above-referenced application.

If any fees are required in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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